



University of Pisa
Department of Civil and Industrial Engineering
Master Degree in Materials and Nanotechnology

Hydrogen storage in three-dimensional arrangement of epitaxial graphene conformally grown on porousified SiC

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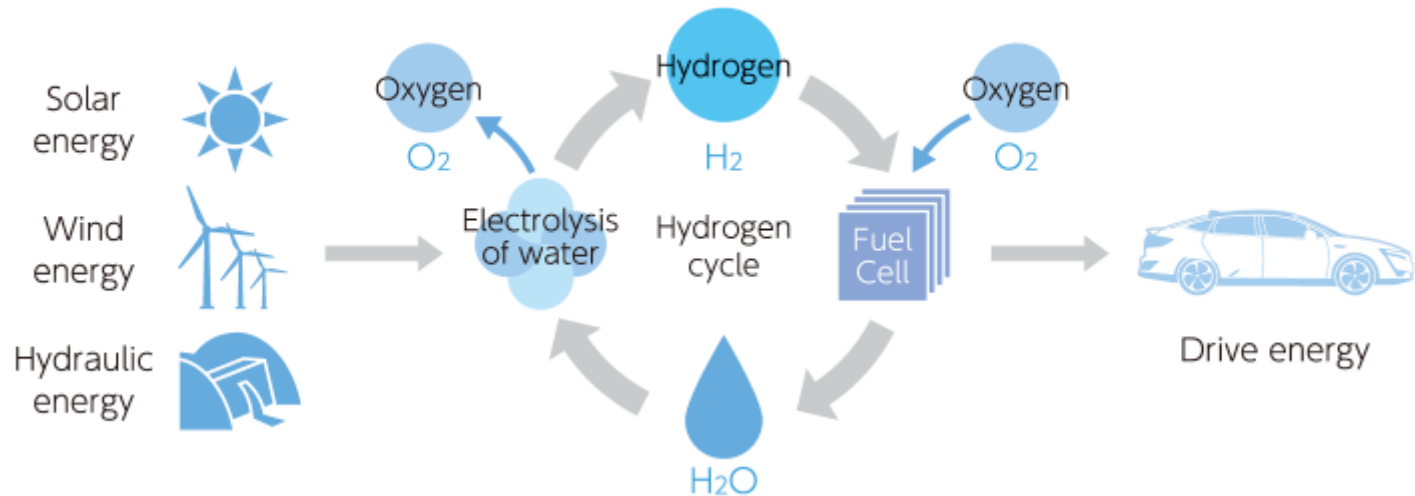
Co-supervisor: Dr. Stefan Heun

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Hydrogen Energy

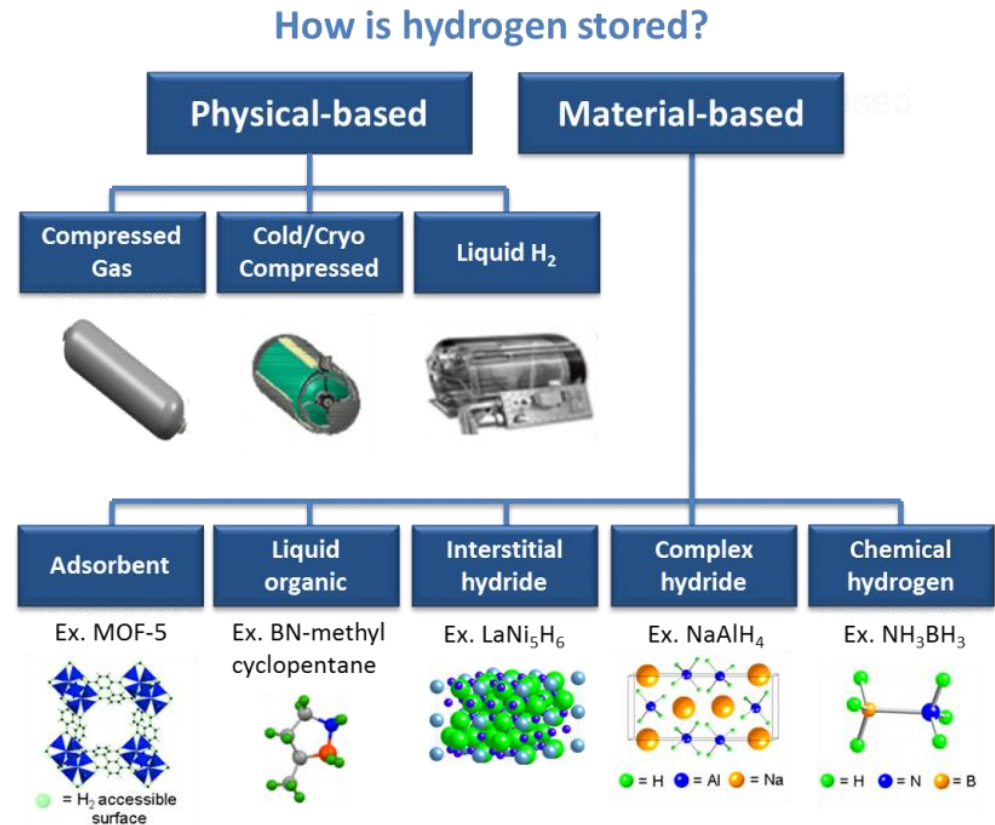
- Fossil fuels are problematic
- Renewables are intermittent
- Conversion into stable compounds
- Advantages of hydrogen

Sustainable Renewable Energy



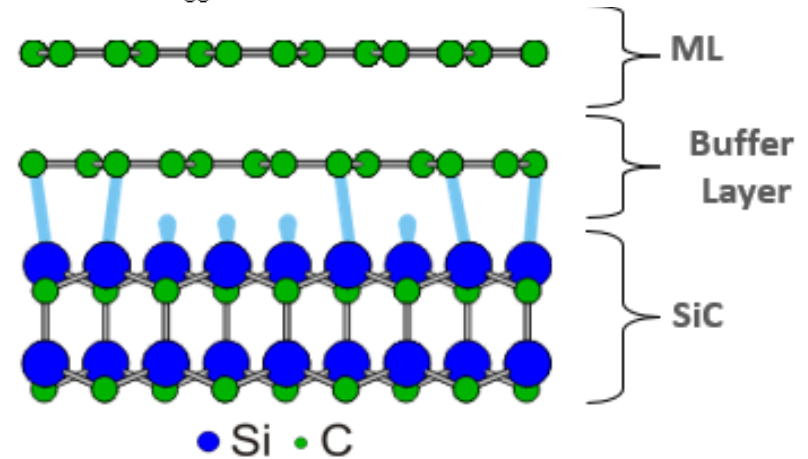
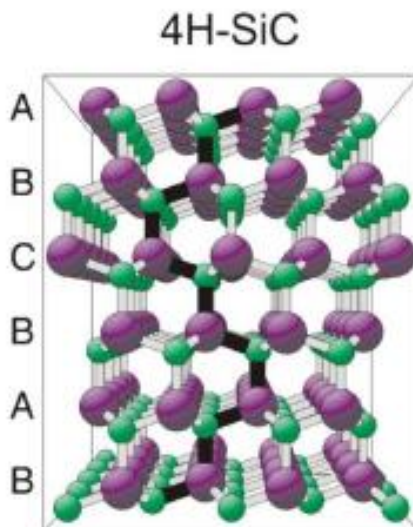
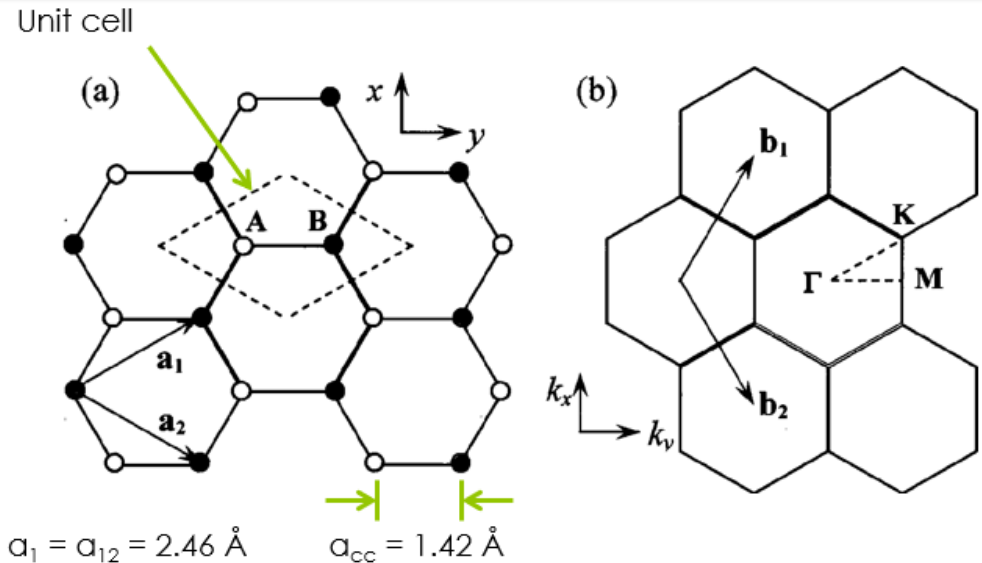
Hydrogen Storage

- Compressed (700 bar, large volume)
- Liquid hydrogen (Cryogenic, 22K)
- Solid state (higher volumetric density, less extreme P and T)
 - Physisorption
 - Chemisorption



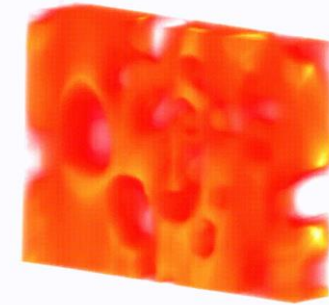
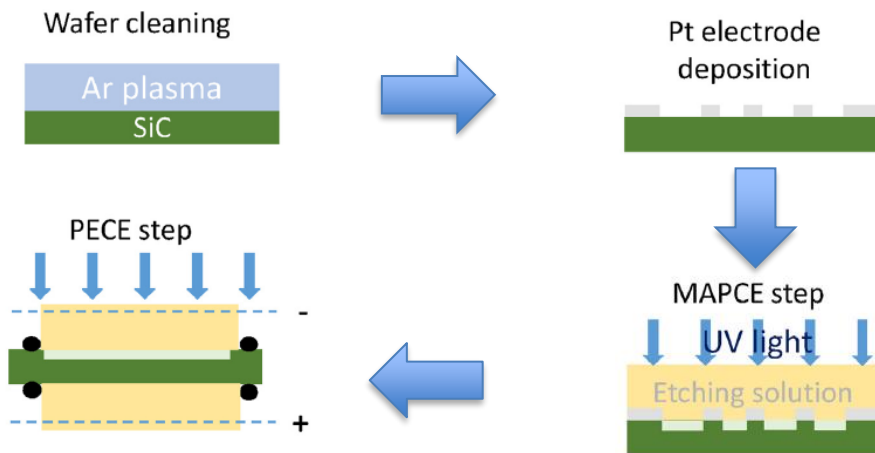
Graphene and Epitaxial Growth

- Hydrogen storage in graphene (cheap, lightweight, inert, functionalization)
- Graphene structure
- Epitaxial graphene (Annealing, Buffer layer)

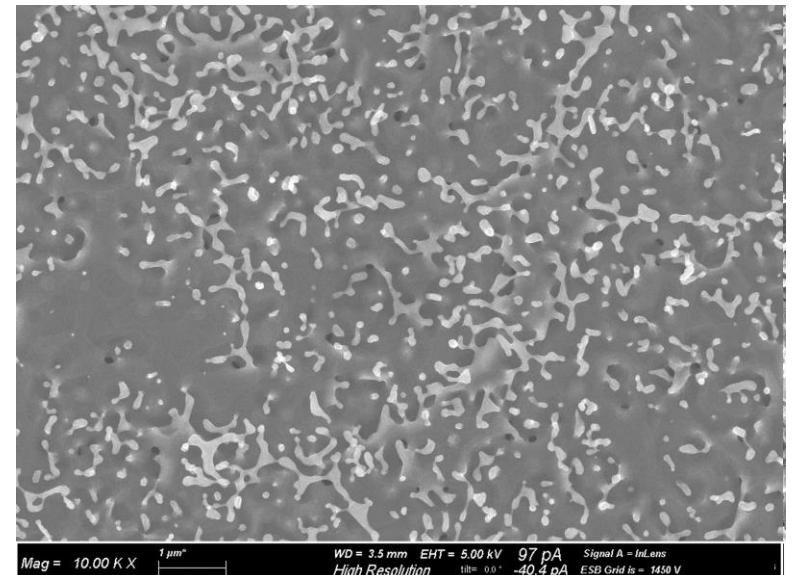


3D Graphene

- Increase surface (graphene foams)
- Photo-Electrochemical etching
- Porous SiC
- 3D graphene (optimal 1370°C)

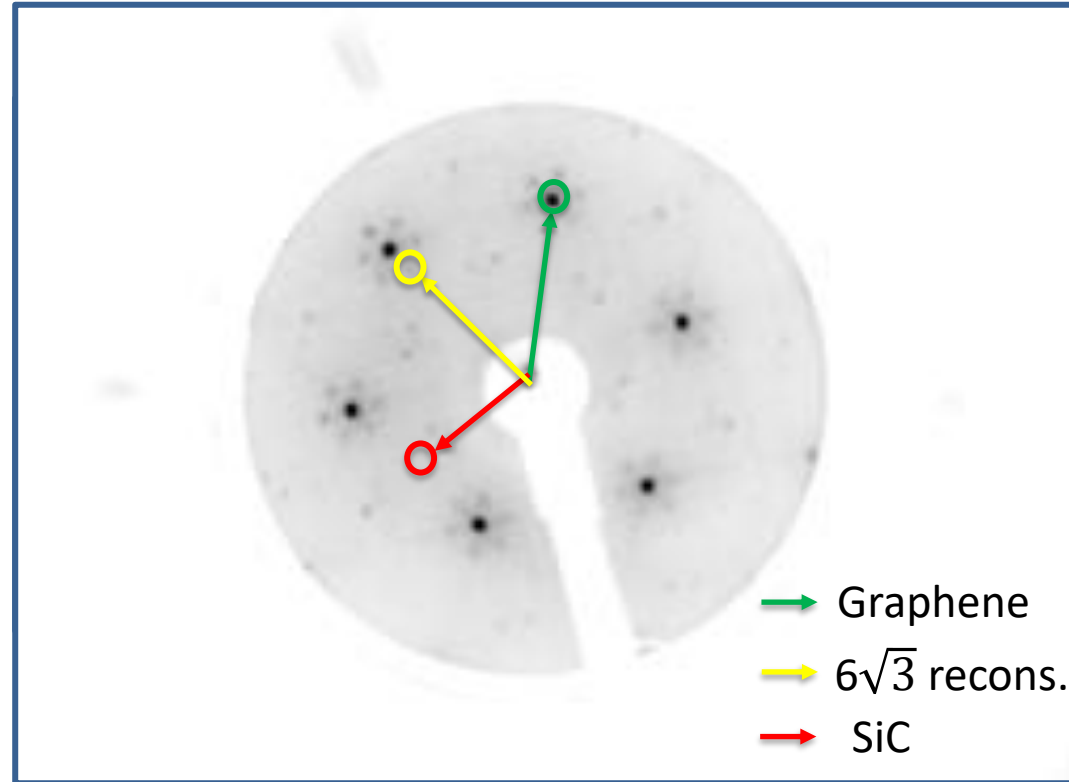


Sara Bals, University of Antrwerp



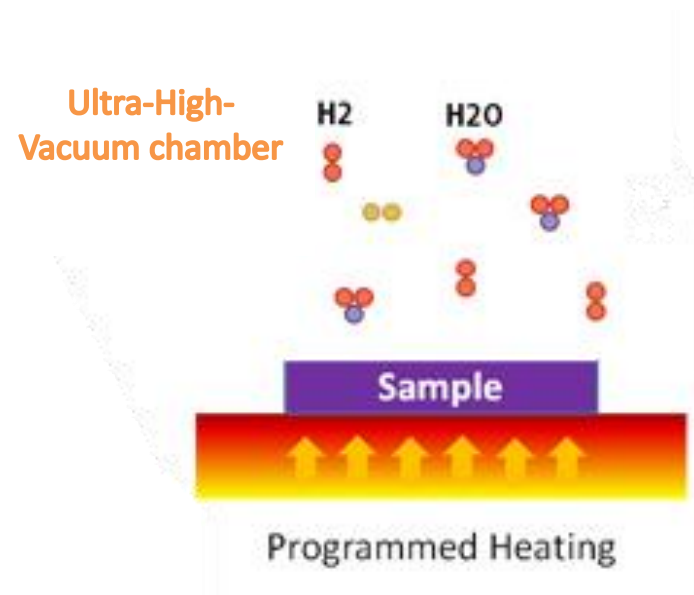
Surface Characterization

- Raman (uniform, high quality graphene)
- STM (atomic resolution)
- LEED (4H SiC, Graphene, Moirè pattern)



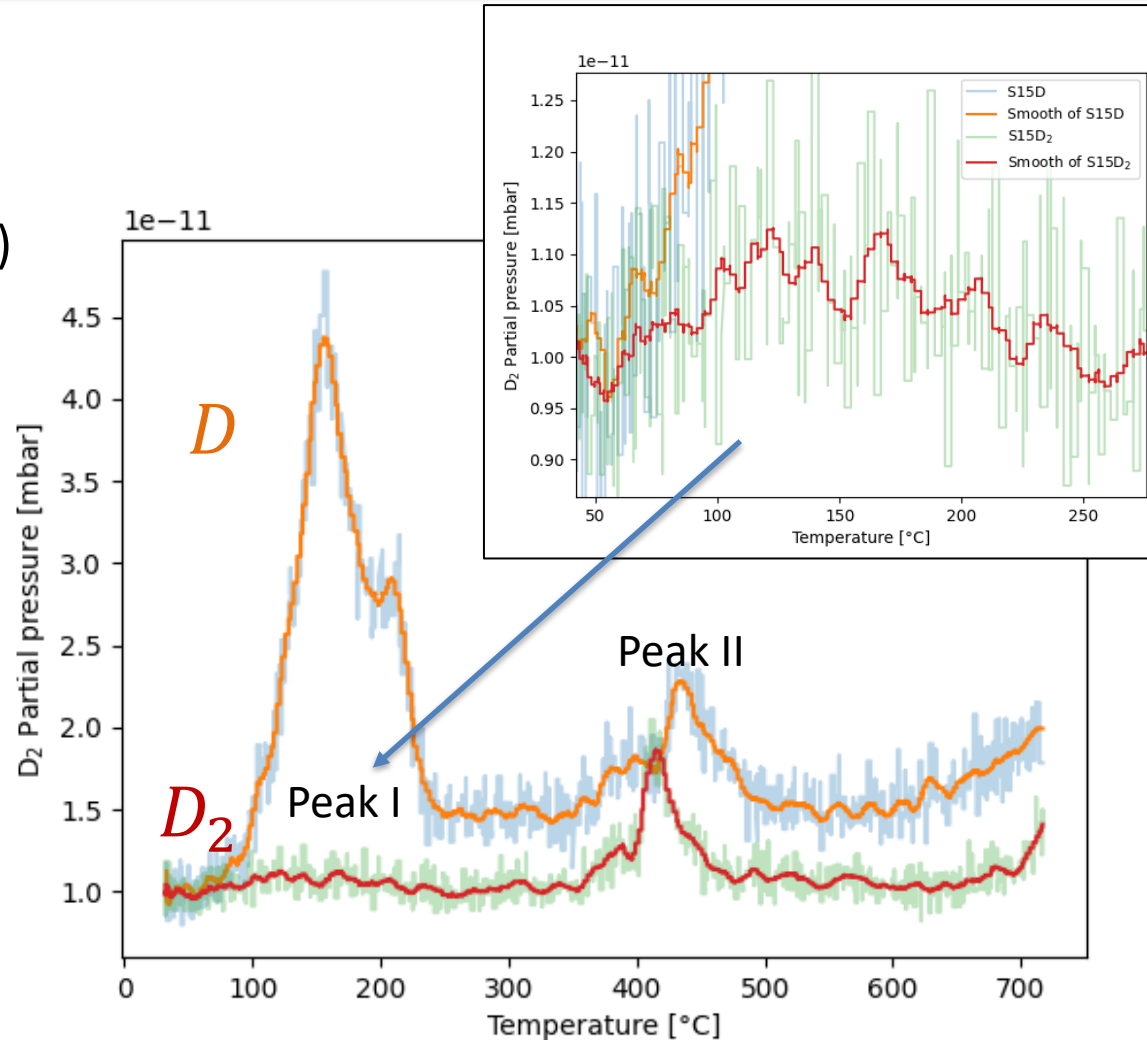
Thermal Desorption Spectroscopy (TDS)

- Principles (hydrogenation, linear heating, PID)
- RGA (m=4)
- 4 different TDS protocols
 - RT exposure TDS
 - LT exposure TDS
 - RT exposure LT TDS
 - Alt. LT exposure TDS



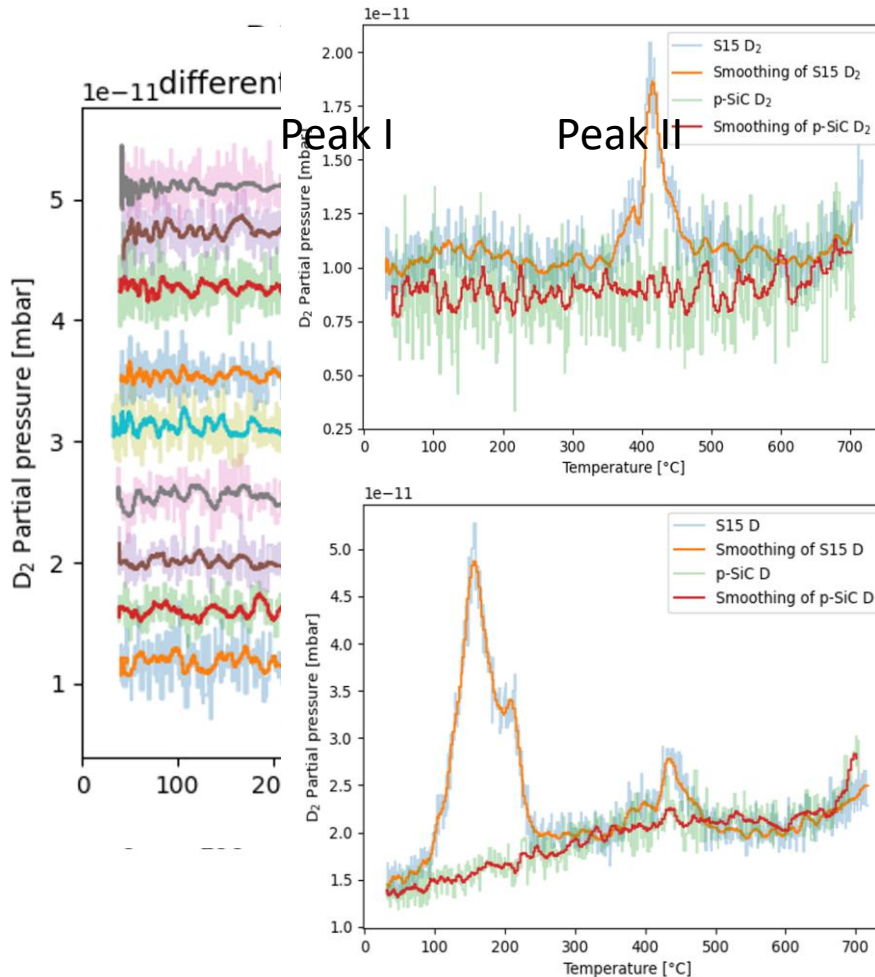
RT exposure TDS

- Room temperature D_2 and D hydrogenation
- Two peaks (1 eV and 1.8 eV)
- Due to chemisorption
- **Presence of a splitting mechanism**



Multiple Annealing RT deposition TDS

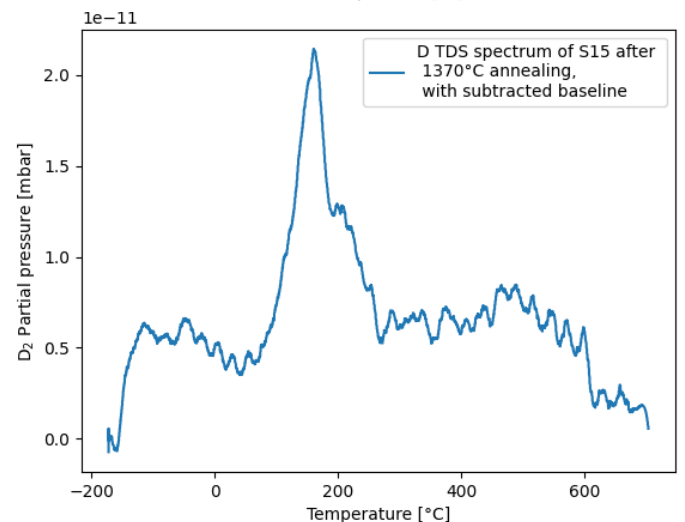
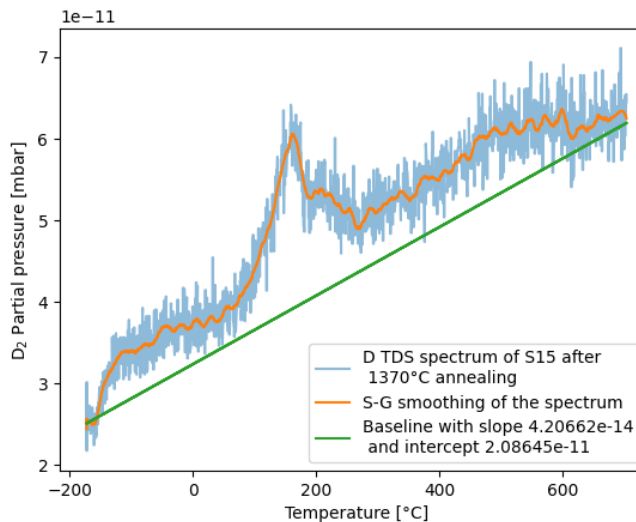
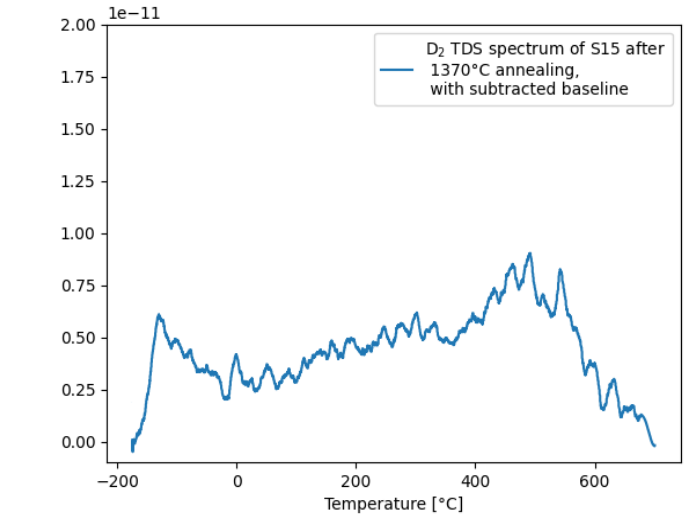
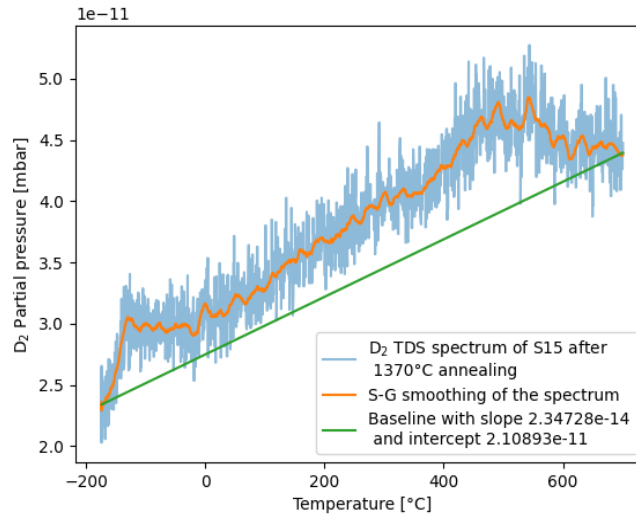
- Porous SiC does not store deuterium
- **Graphene required for storage**
- A series of 8 successive annealing steps (1080°C-1480°C)
- No chemisorption signal with D_2
- Catalytic splitting hindered (possibly due to defects)
- Different spectra with D
- Peak II disappears, peak I appears



nooth of 1483	183
183	
nooth of 1425	125
125	
nooth of 1370	170
170	
nooth of 1309	109
109	
nooth of 1251	151
oth of 1193	193
oth of 1135	135
oth of 1077	177
oth of 700	10

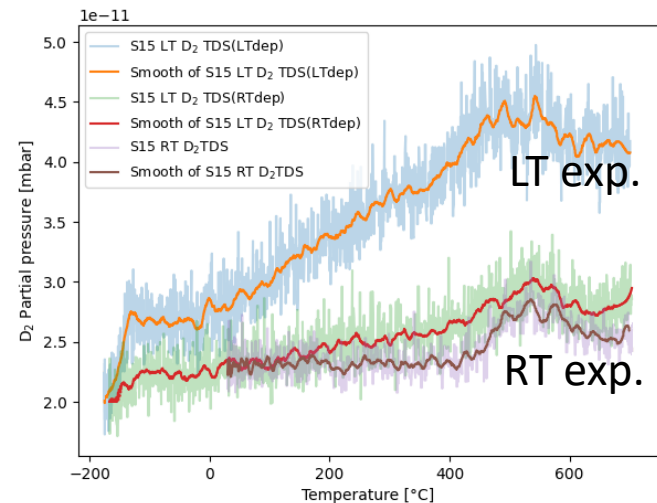
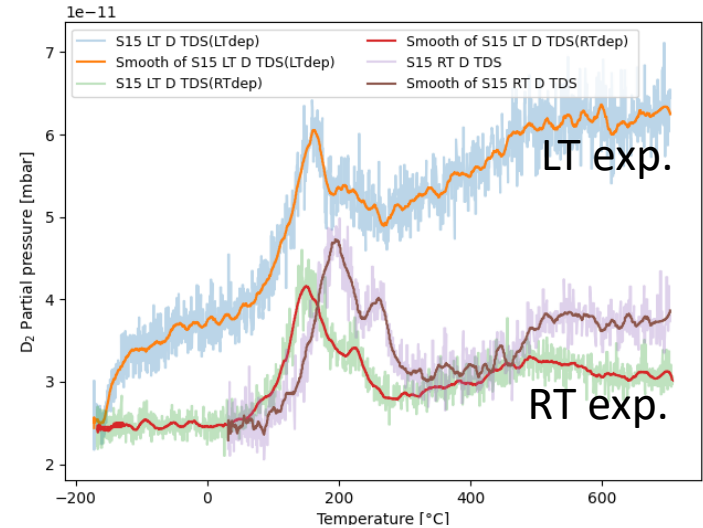
LT exposure TDS

- Sample cooling
- D_2 deposition
- Linear background
- D deposition
- Physisorp. (0.4eV), chemisorption, background increase



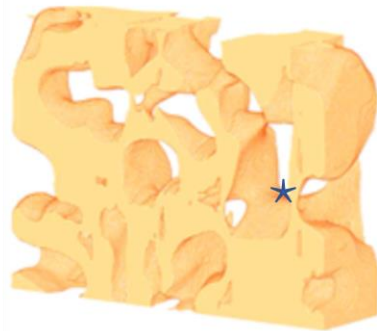
RT exposure LT TDS

- Modified procedure to exclude physisorption
- Background increase and physisorption peak disappear
- **Background trend due to physisorption**
- Also present at high energies



Delayed Emission Model

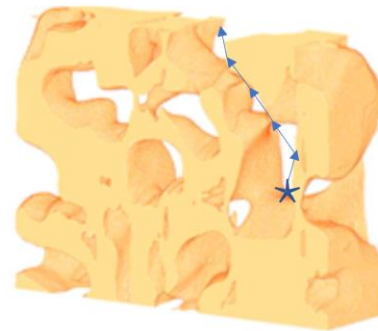
- Energies are too high for physisorption
- Continuous and not discrete emission
- Time lag between emission and detection
- Consistent with LT TDS



Desorption

$$T = T_0$$

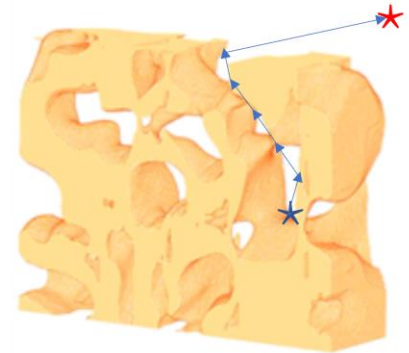
$$\tau = \tau_0$$



Delay

$$T = T_0 + \beta\tau_d$$

$$\tau = \tau_0 + \tau_d$$



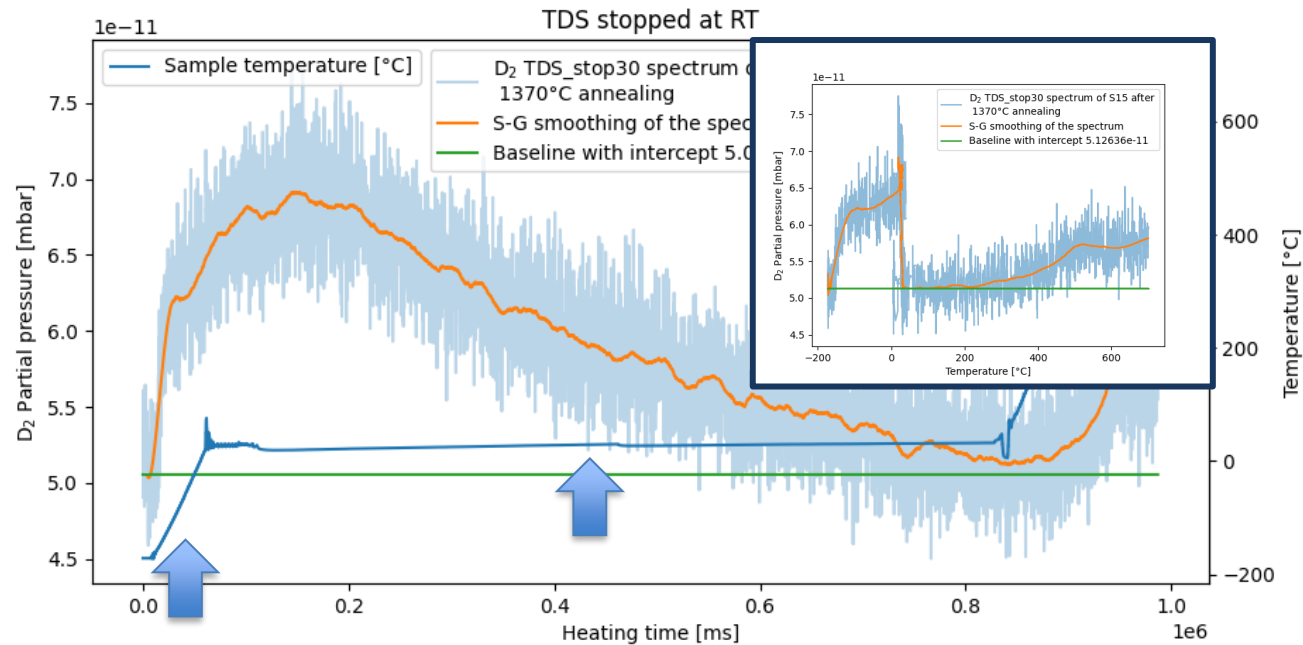
Detection

$$T = T_0 + \beta(\tau_d + \tau_{ex})$$

$$\tau = \tau_0 + \tau_d + \tau_{ex}$$

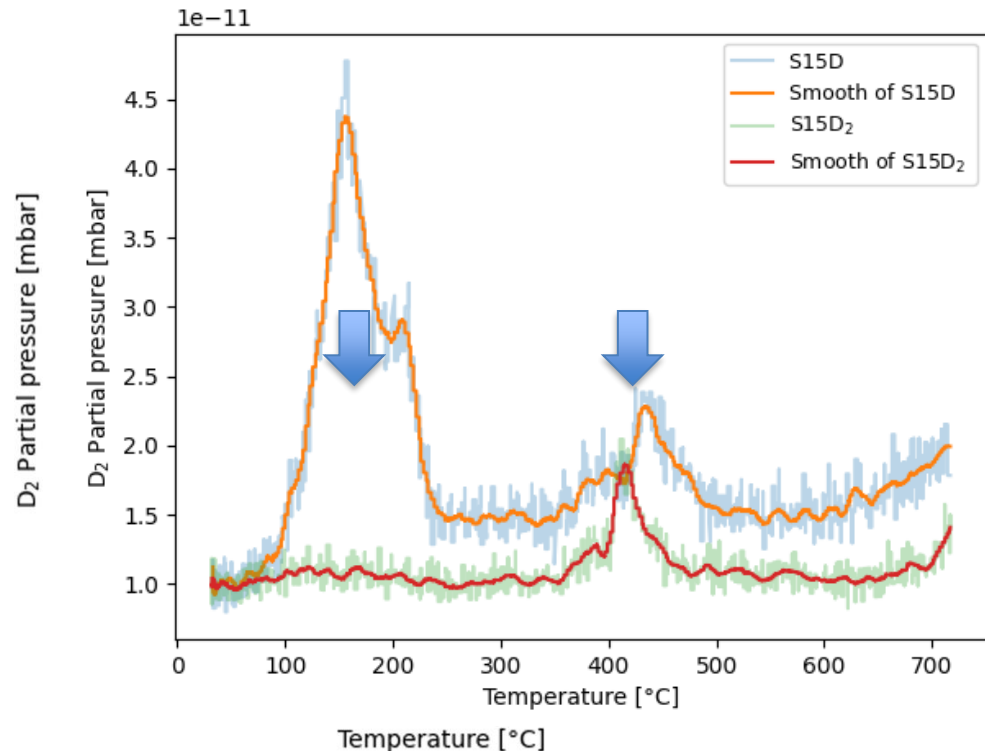
Alternative LT exposure TDS

- Testing the Delayed emission model
- Different TDS plots
- Different heating program
 - Ramp I
 - Temperature Hold
 - Ramp II
- **Consistent with the delayed emission model**
- Common TDS spectrum



Signal Attribution

- Comparison with flat epitaxial graphene
- No chemisorption with D_2
- **Defects introduced by etching**
- SiO_2 and structural defects reported and catalytically active
- **Peak II due to buffer layer**
- **Peak I likely due to dimers**
- Coherent with multiple annealing data



Conclusions

- Synthesis and characterization of a novel 3D graphene structure
- Proof of hydrogen chemisorption, in particular after D_2 hydrogenation
- Effect of the three-dimensionality on hydrogen desorption
- Attribution of chemisorption peaks to physical phenomena

Outlook

- Optimization
 - Material (edges, defects, buffer layer)
 - Hydrogenation procedure (Times)
- Functionalization with active metals (Ti)
- Production of sensors
- Use in electrodes for PEC water splitting

Thank you for your attention
